

Influences of metal oxides on the formation of PXDD/DFs during combustion of trihalogenated phenol gases

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Introduction

Environmental pollution by PXDD/DFs and related compounds has been the subject of public concern. These dioxins are mainly produced from municipal solid waste incinerators (MSWIs). In MSWIs, most of PXDD/DFs can be formed as by-products by the following two general pathways: (1) homogeneous, gas-phase reactions, and (2) heterogeneous, metal-mediated reactions¹⁻²). It was reported that pathway (2) was considered to account for on the order of 70% of all dioxins formation³). Therefore, it has been studied well on the pathway (2) under low-temperature condition (200-500 °C) using metal compounds, which were in fly ash⁴⁻⁶). From these studies, it was cleared that copper and iron compounds promoted the PXDD/DFs formation^{3,7-9}). On the other hand, inorganic compounds contained alkaline earth metal such as calcium and magnesium had suppressing effects on PCDD/DFs formation^{6,10}). However, fly ash and bottom ash are also in a primary combustion furnace, and it is necessary to study the influences of metal oxides on the formation of PXDD/DFs under high-temperature condition (over 600 °C).

In this study, we reported analytical results on the major products of the pathway (1) of 2,4,6-trichlorophenol (2,4,6-T₃CP) or 2,4,6-tribromophenol (2,4,6-T₃BP) as precursors of PXDD/DFs. The amounts of starting materials, halogenated dioxins were studied as a function of temperature. The influences of metal oxides, copper oxide (CuO) or calcium oxide (CaO), on the PXDD/DFs formation from two trihalogenated phenols were also investigated under high-temperature ranging of 500-750°C in dry air stream.

Materials and Methods

Materials

Experiments were performed using 2,4,6-T₃CP, 2,4,6-T₃BP as precursors. These phenols were obtained from Tokyo Chemical Industry Co., Ltd. and their purities were >99 %. CuO, CaO as metal oxides were obtained from Kanto Chemical Co., Inc. and their purities were each >98% and >97%, respectively. Metal oxides were baked at 200 °C for 3 h to remove the impurities. No dioxin compounds as impurities were detected in the starting materials.

Thermal treatment

A laminar airflow, isothermal quartz reaction tube, 225 mm in length and 6 mm in diameter, was used to study the thermal formation of PXDD/DFs and its related compounds from each precursor (Fig. 1). In the quartz reaction tube, 50 mg of metal oxide was fixed at both ends with silica wool, adjusted about 10 mm of thickness, and was held at constant temperature. Each precursor dissolved in diethyl ether were placed on a platinum sample boat and dried at room temperature. Through the heating, the air flow rate and the temperature were regulated to keep constant. The evolved gaseous products were introduced to the water layer and ethanol layer in an ice bath and quenched. These gaseous products in the water layer were extracted twice by 30 ml of diethyl ether. After cooling to room temperature, the residue in the reaction tube, including metal oxide, was rinsed in diethyl ether and it was mixed with diethyl ether extract from the water layer. The combined solvent was concentrated to approximately 2 ml by a rotary evaporator and then concentrated to 1 ml under dry nitrogen gas stream. After addition of 2 ml of n-hexane was added to the sample, again concentrated to approximately 0.5 ml under dry nitrogen gas stream. Finally, phenanthrene-d₁₀ dissolved in n-hexane as an internal standard substance (IS) was added and it was adjusted to 1 ml with n-hexane.

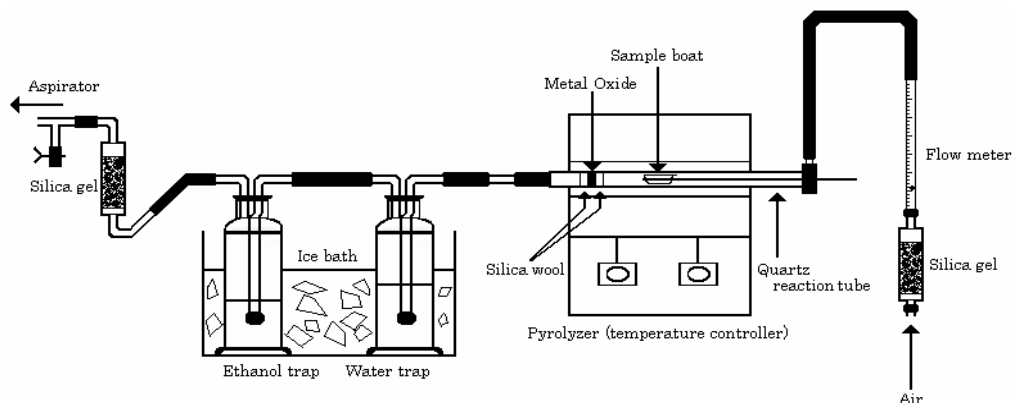


Fig. 1. Schematic diagram of experimental apparatus used for combustion of samples.

Analysis

PXDD/DFs and related compounds were quantified by using Shimadzu GC-14B gas-chromatograph equipped with flame ionization detector and with a fused silica capillary column (ZB-5, 30 m × 0.25 mm i.d., 0.25 μm film thickness). The column oven temperature was initially held at 60°C for 5 min. Secondly, it was raised to 220°C at 10°C/min, and then raised to 280°C at 4 °C /min. Finally, it was held at 280 °C for 10 min. On the other hand, these compounds were qualified by using Varian CP-3800 gas chromatograph equipped with fused silica capillary column (VF-5ms, 30 m × 0.25 mm i.d., 0.25 μm film thickness) with Saturn 2200 mass spectrometer. In the first step, the column oven temperature was held at 60°C for 5 min. In the second step, it was raised to 220°C at 10 °C/min, and then raised to 280°C at 4 °C /min. Finally, it was held at 280 °C for 10 min. Products were identified with those of retention time and mass spectrum.

Results and Discussion

Compositions of products of trihalogenated phenols in a dry air stream

Numerous products were observed from the combustion of 2,4,6-trihalogenated phenols. Figures 2A and 2B show total ion chromatograms obtained from the combustion of 2,4,6-T₃CP and 2,4,6-T₃BP, respectively.

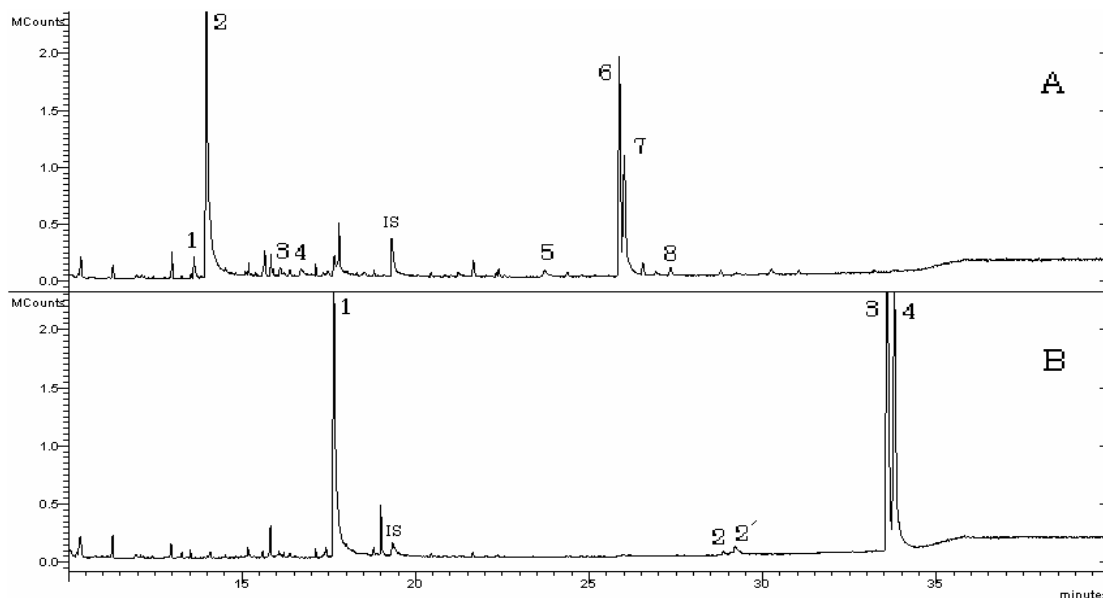


Fig 2. GC-MS total ion chromatograms of combustion products from 2,4,6-T₃XP.
A: 2,4,6-T₃CP at 700 °C, B: 2,4,6-T₃BP at 600 °C

In Figure 2A, starting material (peak 2) and two by-products (peaks 6 and 7) were mainly detected. The compounds, which were detected as peaks 6 and 7 were tetrachlorinated dibenzo-*p*-dioxins (T₄CDDs) as the most abundant intermediate products. Peak 6 was identified to be 1,3,6,8-T₄CDD, and peak 7 was identified to be 1,3,7,9-T₄CDD. Furthermore, four kinds of chlorophenol congeners (corresponding to the peak 4), three kinds of chlorobenzene congeners (corresponding to the peaks 1 and 3) were identified as the minor intermediates. At 700°C, trichlorinated dibenzo-*p*-dioxins (peak 5), tetrachlorinated dibenzofurans, pentachlorinated dibenzo-*p*-dioxins and hexachlorinated dibenzofurans (peak 8) were observed at trace level. At lower than 700°C, trichlorinated dibenzo-*p*-dioxins and pentachlorinated dibenzo-*p*-dioxins could not be observed.

As shown in Figure 2B, starting material (peak 1) and two by-products (peaks 3 and 4) were detected, latter compounds (peaks 3 and 4) were the most abundant intermediate products. Peak 3 and 4 were considered to be 1,3,6,8-tetrabrominated dibenzo-*p*-dioxin (1,3,6,8-T₄BDD) and 1,3,7,9-tetrabrominated dibenzo-*p*-dioxin (1,3,7,9-T₄BDD), respectively. Furthermore, two kinds of bromobenzene congeners, tetrabrominated dibenzofuran and pentabrominated dibenzo-*p*-dioxins were observed at trace level. Peaks 2 and 2' might be isomers of tribrominated dibenzo-*p*-dioxins.

Influence of temperature on the formation of PXDD/DFs.

The maximum amounts of two T₄CDDs (1,3,6,8-T₄CDD and 1,3,7,9-T₄CDD) obtained from the combustion of 2,4,6-T₃CP were about 2.2 % (mol/mol) of compounds at 700°C (Fig. 3). Similar phenomenon also occurred about T₄BDD formation. The maximum amounts of two T₄BDDs (1,3,6,8-T₄BDD and 1,3,7,9-T₄BDD) obtained from the combustion of 2,4,6-T₃BP were about 3.3 % (mol/mol) of compounds at 600°C (Fig. 4). The temperature observed the maximum amounts of two T₄XDDs was somewhat higher than that of previous study¹¹. This phenomenon was due to shortening the contacting time in the dry air stream.

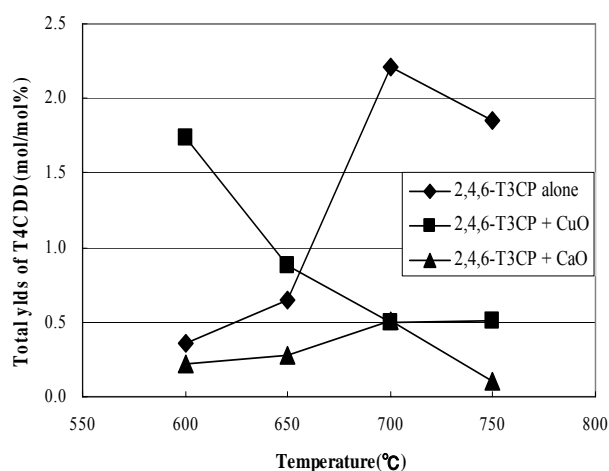


Fig 3. Influences of metal oxides on the total yields of T₄CDD from the combustion of 2,4,6-T₃CP, as a function of temperature (residence time: 2 sec).

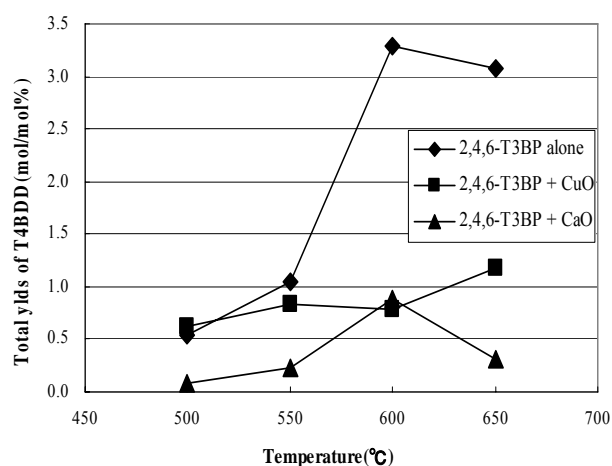


Fig 4. Influences of metal oxides on the total yields of T₄BDD from the combustion of 2,4,6-T₃BP, as a function of temperature (residence time: 2 sec).

Influence of contacting metal oxides on the formation of PXDD/DFs.

Under low-temperature condition (200-500 °C), copper compounds catalyzed the formation of PXDD/DFs during combustion of halogenated phenols, in contrast, calcium compounds suppressed the formation of PXDD/DFs. As shown in Fig. 3, CuO catalyzed the formation of T₄CDDs at 600°C and the total yields of T₄CDDs increased about 5 times, as compared with 2,4,6-T₃CP combustion without CuO. In the thermal reaction with CuO, most of 2,4,6-T₃CP might be decomposed. However, at 700°C, total amounts of T₄CDD decreased

about one fourth, as compared with 2,4,6-T₃CP combustion without CuO. Slightly catalytic effect on T₄BDDs formation by CuO was observed in the thermal reaction of 2,4,6-T₃BP at 500°C (Fig.4). On the other hand, suppressing effect on the total amount of T₄BDD was observed at 600°C, and it decreased about one sixth, as compared with 2,4,6-T₃BP combustion without CuO. This result might be influenced by the oxidative decomposition. The temperature observed decreasing of T₄CDDs and T₄BDDs amounts comparing with the combustion without CuO were over 660°C, and over 525°C, respectively.

Formation of T₄CDDs during the thermal reaction with CaO was suppressed at every temperature (Fig. 3). In this study, suppression ratios of T₄CDDs, as compared with T₄CDDs formation obtained for 2,4,6-T₃CP combustion without CaO, were 39.2-94.2 %. Formation of T₄BDDs during the thermal reaction with CaO was also suppressed at every temperature and suppression ratios of T₄BDDs, as compared with T₄BDDs formation obtained for 2,4,6-T₃BP combustion without CaO, were 72.9-89.7 %. In the previous studies, this preventing effect of T₄XDDs formations on 2,4,6-T₃XP combustion based on abstracting the proton of 2,4,6-T₃XP and giving electron were reported under low-temperature condition^{6,10}. On the other hand, the amounts of T₄XDDs also decreased, as compared with 2,4,6-T₃CP combustion without CaO under high-temperature condition in our study, therefore, the same suppressing effect might be involving.

Conclusion

The thermal reactions of 2,4,6-T₃CP or 2,4,6-T₃BP in a dry air stream were studied using a laboratory-scale quartz tube reactor, with or without metal oxides. T₄XDDs as major products, and halogenated benzenes, phenols and other PXDD/DFs isomer as minor ones produced. Contacting with CuO, T₄CDDs formation from 2,4,6-T₃CP were promoted below about that temperature. However, decomposition effect of T₄CDDs by CuO was observed over 660°C. In contrast, T₄BDDs formation from 2,4,6-T₃BP were promoted below about 525°C, and were inverted over about that temperature. On the other hand, in the case of CaO, T₄XDDs formation were inhibited and yields of T₄XDD decreased at every temperature.

References

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